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(37 CFR 1.98(b))

APPLICANT
MacDougall, et al.

FILING DATE

01/14/2002

GROUP

1725

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D.B.

8-21-02

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5	8	5	8	4	5	7					
SJS	5	8	5	8	4	5	7	1/12/99	Brinker, et al	427	162	9/25/97
SJS	5	6	4	5	8	9	1	7/8/97	Liu, et al	427	376.2	11/23/94
SJS	5	9	5	5	1	4	0	9/21/99	Smith, et al	427	96	11/14/96
SJS	5	0	2	1	3	9	8	6/4/91	Sharma, et al	505	1	10/26/89
SJS	4	0	1	0	1	3	3	3/1/77	Takashi Nakayama	260	29.6	3/2/73
SJS	5	8	5	8	5	2	6	1/12/99	Floch, et al	428	327	7/13/94
SJS	5	6	0	5	6	2	8	2/25/97	Davidson, et al	210	321.83	12/6/94
SJS	6	1	2	0	8	9	1	9/19/00	Balkus, Jr., et al	428	336	10/29/97
SJS	6	0	2	7	6	6	6	2/22/00	Ozin, et al	252	301.4 R	6/5/98
SJS	5	9	2	2	2	9	9	7/13/99	Bruinsma, et al	423	335	8/26/97
SJS	5	9	5	5	1	4	0	9/21/99	Smith, et al	427	96	11/14/96
SJS	5	8	8	9	4	4	9	3/30/99	Slawomir J. Fiedziuszko	333	239	12/7/95
SJS	6	0	1	1	1	6	7	1/4/00	Tashiro, et al	556	410	12/26/97
SJS	5	9	6	9	0	8	8	10/19/99	Ezzell, et al	528	353	5/5/98
SJS	6	2	0	8	0	1	4	3/27/01	Wu, et al	257	629	1/22/99
SJS	6	2	1	1	0	9	6	4/3/01	Allman, et al	438	787	3/21/97

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
	9	9	3	7	7	0	5						
SJS	9	9	3	7	7	0	5	7/29/99	WO	C08J	9/00	x	
SJS	0	0	3	9	0	2	8	7/6/00	WO	C01B	37/02	X	
SJS	0	0	3	7	3	7	4	6/29/00	WO	C03C	17/00	x	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

SJS	"Introduction to Ceramics" p. 948, John Wiley & Sons, Inc., 1970.											
	"Sol-Gel Science", p. 118, Academic Press, Inc., Harcourt Brace Jovanovich Publishers, 1990.											
SJS	"Nanoporous Silica For Low K Dielectrics", Ramos, et al, 443 Mat. Res. Soc. Symp. Vol. 91, 1997.											
	"Pore Structure Characterization of Porous Films", Glaves, et al, 5 Langmuir 459-66, 1989.											
SJS	"Microporous and Mesoporous Materials", Impens, et al, 1999, 28, 217-232.											
	"A New Family of Mesoporous Molecular Sieves Prepared With Liquid Crystal Templates", Beck, et al, 114 J.Am. Chem. Soc. 10834-43, 1992.											
SJS	Characterization of Engineering Surfaces By Grazing-Incidence X-ray Reflectivity", Bowen, et al, Nanotechnology, 4, p. 175-182, 1993.											
	Derwent (2000-482474)											
SJS	Derwent (2000-490810)											

EXAMINER

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